



Attorney's Docket No.: 10417-084001 / F51-134741M/SW

2815  
EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Izuo Iida  
Serial No. : 09/876,554  
Filed : June 7, 2001  
Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : 2815  
Examiner : N. Drew Richards

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 28, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

JULY 28, 2004

Date of Deposit

Signature

PATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate